

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.,
TSMC NORTH AMERICA CORPORATION,
FUJITSU SEMICONDUCTOR LIMITED,
FUJITSU SEMICONDUCTOR AMERICA, INC.,
ADVANCED MICRO DEVICES, INC., RENESAS ELECTRONICS
CORPORATION, RENESAS ELECTRONICS AMERICA, INC.,
GLOBAL FOUNDRIES U.S., INC., GLOBALFOUNDRIES DRESDEN
MODULE ONE LLC & CO. KG, GLOBALFOUNDRIES DRESDEN MODULE
TWO LLC & CO. KG, TOSHIBA AMERICA ELECTRONIC COMPONENTS,
INC., TOSHIBA AMERICA INC., TOSHIBA AMERICA INFORMATION
SYSTEMS, INC., TOSHIBA CORPORATION, and
THE GILLETTE COMPANY,

Petitioners

v.

ZOND, LLC
Patent Owner

Case No. IPR2014-00808¹
Patent 7,604,716 B2

**AFFIDAVIT OF MARIA GRANOVSKY IN SUPPORT OF PATENT
OWNER'S MOTION FOR *PRO HAC VICE* ADMISSION**

I, Maria Granovsky, being duly sworn and upon oath, hereby attest to the

¹ Cases IPR 2014-00849, IPR 2014-00975, and IPR 2014-01067 have been joined
with the instant proceeding.

following:

- i. I am a member in good standing of the New York and Delaware Bars, as well as the U.S. District Court for the District of Delaware.
- ii. I have not been suspended or disbarred from practice before any court or administrative body.
- iii. I have never had an application for admission to practice before any court or administrative body denied.
- iv. No sanction or contempt citation has been imposed against me by any court or administrative body.
- v. I have read and will comply with the Office Patent Trial Practice Guide and the Board's Rules of Practice for Trials set forth in part 42 of the Code of Federal Regulations.
- vi. I will be subject to the USPTO Rules of Professional Conduct set forth in 37 C.F.R. §§ 11.101 *et seq.* and disciplinary jurisdiction under 37 C.F.R. § 11.19(a).
- vii. Other than presently applying to appear *Pro Hac Vice* before the Office in connection with the *Inter Partes* Review proceedings of the patents listed below in section ix, I have not applied to appear *Pro Hac Vice* before the Office in any other proceeding in the last three years.
- viii. I am an experienced litigation attorney, with experience in many

litigations involving patent infringement in District Courts across the country, including experience with fact and expert document and deposition discovery, claim construction, *Markman* hearings, motion practice, trials and hearings.

- ix. I am counsel for Patent Owner Zond, LLC, the plaintiff in several related on-going litigations. I am familiar with the subject matter at issue in this proceeding as a result of my representation of Zond, LLC, in a matter currently before the District of Massachusetts (*Zond v. TSMC, et al.*, No. 1:14-cv-12438-WGY), in which the patents 6896775, 6896773, 6806651, 6903511, 7095179, and 7446479 have been asserted against several TSMC and Fujitsu entities. I am familiar with the prior art that Petitioner presents in this proceeding, as well as issues of claim construction as a result of my participation in the above litigation and related work that I have done on behalf of Zond.

Date: November 25, 2014

/Maria Granovsky/
Maria Granovsky
RADULESCU LLP
Empire State Building, Suite 6910
350 Fifth Avenue,
New York, NY 10118
maria@Radulescullp.com